Formation of advanced nanostructured coatings by hybrid electron beam process

Prof. B. Movchan

E.O. Paton Electric Welding Institute of NASU Ukraine, Kiev <u>movchan@paton-icebt.kiev.ua</u>

The paper deals with variants of electron beam processes of evaporation and subsequent condensation of inorganic substances at the rates of 1 - 50 μ m/min, combining the traditional processes of physical and chemical deposition (PVD and CVD).

The paper presents the developed functional and structural metal, ceramic and metal-ceramic coatings (thick films) of $5-10 \mu m$ up to 1-2 mm thickness with specified nano- and microsized structural elements (grains, phase particles, pores and layers).

Composition and quantity of the initial evaporated substances, temperature of the condensation substrate, active gases (N_2 , O_2 , etc.) bled into the working chamber and vapours of reactive substances, additionally evaporated in the working chamber, are the main process parameters, allowing adjustment of the coating structure and properties in a broad range.

The paper gives examples of "structure-property" dependencies, in particular, dimensional-structural effects of hardness of two-phase coatings with a dispersed and laminated structure.

Areas of practical application of thick films and directions of further investigations and developments are noted.